

What is claimed is:

1. A semiconductor circuit designing apparatus, comprising:

a circuit design unit executing a logical design of a semiconductor integrated circuit; and

5 an inspection item database section in which a circuit feature of said semiconductor integrated circuit corresponds to an inspection item of a inspection to be executed before a layout design of said semiconductor integrated circuit is executed, and

10 wherein said circuit design unit generates a target circuit feature information indicating said circuit feature of a target semiconductor integrated circuit of said semiconductor integrated circuit of which said logical design  
15 should be executed, and

20 wherein said circuit design unit obtains a target inspection item of said inspection item corresponding to said target circuit feature information from said inspection item database section, and

25 wherein said circuit design unit executes said logical design of said target semiconductor integrated circuit in reference to said target inspection item.

2. The semiconductor circuit designing apparatus according to Claim 1, further comprising:

a model development history database  
5 section in which an ID data of said circuit design unit corresponds to the number of times said circuit design unit failed said inspection of said inspection item previously, and

10 wherein said target inspection item is determined such that said inspection item of which said number of times is smaller than a predetermined value is withdrawn from said target inspection item.

3. The semiconductor circuit designing apparatus according to Claim 1, further comprising:

a layout design unit executing said layout  
5 design, and

wherein said circuit design unit executes said inspection of said target semiconductor integrated circuit of which said layout design is executed, with regard to said target inspection  
10 item, and

wherein said circuit design unit provides a result of said inspection with said target semiconductor integrated circuit to said layout

design unit.

4. The semiconductor circuit designing apparatus according to Claim 2, further comprising:

5 a layout design unit executing said layout design, and

wherein said circuit design unit executes said inspection of said target semiconductor integrated circuit of which said layout design is executed, with regard to said target inspection item, and

wherein said circuit design unit provides a result of said inspection with said target semiconductor integrated circuit to said layout design unit.

5. The semiconductor circuit designing apparatus according to Claim 4, wherein when said provided result of said inspection has no problem, said layout design unit stores said ID data of  
5 said circuit design unit and said number of times said circuit design unit failed said inspection of said target inspection item in said model development history database section.

6. The semiconductor circuit designing

apparatus according to Claim 1, wherein said inspection item database section belongs to said circuit design unit.

7. The semiconductor circuit designing apparatus according to Claim 2, wherein said inspection item database section belongs to said circuit design unit.

8. The semiconductor circuit designing apparatus according to Claim 3, wherein said inspection item database section belongs to said layout design unit.

9. The semiconductor circuit designing apparatus according to Claim 4, wherein said inspection item database section belongs to said layout design unit.

10. The semiconductor circuit designing apparatus according to Claim 5, wherein said inspection item database section belongs to said layout design unit.

11. The semiconductor circuit designing apparatus according to Claim 3, wherein said layout design unit includes a plurality of layout

design sections, and

5            wherein said inspection item database  
section belongs to at least one of said plurality  
of layout design sections.

12.        The semiconductor circuit designing  
apparatus according to Claim 3, further  
comprising:

5            a data center provided to be different from  
said circuit design unit and said layout design  
unit, and

           wherein said inspection item database  
section belongs to said data center.

13.        A semiconductor circuit designing method,  
comprising:

5            (a) providing a inspection item database  
section in which a circuit feature of a  
semiconductor integrated circuit in which a  
logical design should be executed corresponds to  
an inspection item of a inspection to be executed  
before a layout design of said semiconductor  
integrated circuit is executed;

10           (b) notifying a circuit designer executing  
said logical design of said semiconductor  
integrated circuit of said inspection item  
corresponding to said semiconductor integrated

circuit retrieved from said inspection item  
15 database section; and

(c) executing said logical design of said semiconductor integrated circuit by said circuit designer in reference to said notified inspection item.

14. The semiconductor circuit designing method according to Claim 13, further comprising:

(d) providing said semiconductor integrated circuit in which said notified inspection item is  
5 passed to a layout designer executing said layout design.

15. The semiconductor circuit designing method, comprising:

(e) providing a circuit design unit  
executing a logical design of a semiconductor  
5 integrated circuit; and

(f) providing an inspection item database section in which a circuit feature of said semiconductor integrated circuit corresponds to an inspection item of a inspection to be executed  
10 before a layout design of said semiconductor integrated circuit is executed, and

wherein said circuit design unit generates a target circuit feature information indicating

said circuit feature of a target semiconductor  
15 integrated circuit of said semiconductor  
integrated circuit of which said logical design  
should be executed, and

wherein said circuit design unit obtains a  
target inspection item of said inspection item  
20 corresponding to said target circuit feature  
information from said inspection item database  
section, and

wherein said circuit design unit executes  
said logical design of said target semiconductor  
25 integrated circuit in reference to said target  
inspection item.

16. The semiconductor circuit designing method  
according to Claim 15, further comprising:

(g) providing a model development history  
database section in which an ID data of said  
5 circuit design unit corresponds to the number of  
times said circuit design unit failed said  
inspection of said inspection item previously, and

wherein said target inspection item is  
determined such that said inspection item of which  
10 said number of times is smaller than a  
predetermined value is withdrawn from said target  
inspection item.

17. The semiconductor circuit designing method according to Claim 15, further comprising:

(h) providing a layout design unit executing said layout design, and

5 wherein said circuit design unit executes said inspection of said target semiconductor integrated circuit of which said layout design is executed, with regard to said target inspection item, and

10 wherein said circuit design unit provides a result of said inspection with said target semiconductor integrated circuit to said layout design unit.

18. The semiconductor circuit designing method according to Claim 16, further comprising:

(i) providing a layout design unit executing said layout design, and

5 wherein said circuit design unit executes said inspection of said target semiconductor integrated circuit of which said layout design is executed, with regard to said target inspection item, and

10 wherein said circuit design unit provides a result of said inspection with said target semiconductor integrated circuit to said layout design unit.



19. The semiconductor circuit designing method according to Claim 18, wherein when said provided result of said inspection has no problem, said layout design unit stores said ID data of said  
5 circuit design unit and said number of times said circuit design unit failed said inspection of said target inspection item in said model development history database section.

20. The semiconductor circuit designing method according to Claim 15, wherein said inspection item database section belongs to said circuit design unit.